



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ko et al.

Serial No.: 09/585,682

Filed: June 1, 2000

For: SEMICONDUCTOR DEVICE
HAVING A SUBSTRATE, AN UNDOPED
SILICON OXIDE STRUCTURE, AND AN
OVERLYING DOPED SILICON OXIDE
STRUCTURE WITH A SIDEWALL
TERMINATING AT THE UNDOPED
SILICON OXIDE STRUCTURE (Amended)

Confirmation No.: 7481

Examiner: C. Chu

Group Art Unit: 2815

Attorney Docket No.: 2269-3526.2US
(97-1136.02/US)

Notice of Allowance Mailed:

September 29, 2006

NOTICE OF EXPRESS MAILING

Express Mail Mailing Label Number: EV 826303005 US

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Person making Deposit: Brett Hooke

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

Amendments to the specification begin on page 3 of this paper;

Amendments to the Abstract appear on page 9 of this paper;

A listing of the claims begins on page 10 of this paper; and

Remarks start at page 13 of this paper.